



Docket No.: 050389-0052

PATENT

Reply Under 37 CFR 1.116 - Expedited Procedure - Technology Center 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chihiro KAWAI, et al.

Application No.: 10/500,975

Customer No.: 20277

Filed: July 08, 2004

Confirmation No.: 3373

Group Art Unit: 2811

Examiner: Andrew O. Arena

Title: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of April 1, 2008, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 16 of this paper.